





ion Choroe

New Possibilities in High-End TEM Instrumentation and In Situ Analysis in Gas and Liquid Environments

Overview

The Workshop is organized by Protochips Inc., Nano Instruments Ltd., the Electron Microscopy Center in the Department of Materials Science & Engineering, in the Technion and supported by ISM. Applications scientists from Protochips Inc., in collaboration with the Technion EM Center team, will introduce and demonstrate new tools for in situ TEM analysis and show applications in life and materials science. The keynote lectures will accompany the subsequent parallel sessions on in situ TEM.

Program and demonstration schedule (Program subject to modification)

Tuesday, 13th October

10:00	Get together with refreshments
10:15	Welcome
10:30	A new paradigm in environmental TEM:
	Applications and capabilities of the
	Atmosphere Gas E-Cell System
11:30	Dynamic Temperature and Electrical

control within the TEM
12:15 Lunch Break

13:00 Parallel Hands on Demo sessions

15:00 Short Coffee Break

15:15 Parallel Hands on Demo sessions

17:15 End of first day

Wednesday, 14th October

10:00	Get together with refreshments			
10:15	Imaging in Solution:			
	Imaging Wet Specimen in situ using EM			
11:15	Liquid cell - Sample preparation process			
12:00	Lunch Break			
13:00	Parallel Hands on Demo sessions			
15:00	Short Coffee Break			
15:15	Parallel Hands on Demo sessions			
17:15	End of Workshop			

Location

Technion - Israel Institute of Technology Department of Materials Sciences & Engineering

Lectures: Auditorium, floor 3

Demonstrations: Electron Microscopy Center,

floor 0



Demonstrations program					
	Time	Tuesday	Wednesday		
Titan Room	13:00	Group 1	Group 3		
(Poseidon)	15:15	Group 2	Group 4		
T-20 Room	13:00	Group 2	Group 4		
(Aduro)	15:15	Group 1	Group 3		

Registration

Registration is free for the workshop. However, due to limited seating and space in the TEM rooms, attendees must register for the lectures and the demonstrations. Lunch will be provided every day of the workshop.

Register Here

Deadline for registration:

Thursday, October 8th, 2015

Contacts

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